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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
09/588,696	06/07/2000	Yujiro Suzuki	325772017700	325772017700 8631	
75	90 04/03/2002				
Barry E Bretschneider			EXAMINER		
	nia Avenue NW		LEUNG, QÚ	LEUNG, QUYEN PHAN	
Washongton, D	C 20006-1888		ART UNIT PAPER NUMBER 2828		
			DATE MAILED: 04/03/2002	DATE MAILED: 04/03/2002	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)				
Office Author O	09/588,696	SUZUKI, YUJIRO				
Office Action Summary	Examiner	Art Unit				
	Quyen P. Leung	2828				
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply						
A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a reply - If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, - Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).  Status	36(a). In no event, however, may a reply be time within the statutory minimum of thirty (30) days will apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	nely filed s will be considered timely. the mailing date of this cor O (35 U.S.C. § 133).				
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• • • • • • • • • • • • • • • • • • • •	· is action is non-final.					
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.  Disposition of Claims						
4)⊠ Claim(s) 1-17 is/are pending in the application						
4a) Of the above claim(s) is/are withdrawn from consideration.						
5) Claim(s) is/are allowed.						
6)⊠ Claim(s) <u>1-17</u> is/are rejected.						
7) Claim(s) is/are objected to.						
8) Claim(s) are subject to restriction and/or election requirement.						
Application Papers						
9) The specification is objected to by the Examiner.						
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.						
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).  11) The proposed drawing correction filed on is: a) approved b) disapproved by the Examiner.						
· · · · · · · · · · · · · · · · · · ·		ved by the Examine	г.			
If approved, corrected drawings are required in reply to this Office action.  12) The oath or declaration is objected to by the Examiner.						
	arriiner.					
Priority under 35 U.S.C. §§ 119 and 120						
13) Acknowledgment is made of a claim for foreign	priority under 35 U.S.C. § 119(a)	)-(d) or (f).				
a)⊠ All b)□ Some * c)□ None of:						
1. ☐ Certified copies of the priority documents						
2. Certified copies of the priority documents						
<ul> <li>3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).</li> <li>* See the attached detailed Office action for a list of the certified copies not received.</li> </ul>						
14) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).						
a) ☐ The translation of the foreign language provisional application has been received.  15) ☐ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.						
Attachment(s)						
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449) Paper No(s) 4.	5) Notice of Informal P	(PTO-413) Paper No(s Patent Application (PTO				
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### **DETAILED ACTION**

### Claim Rejections - 35 USC § 112

1. The following is a quotation of the second paragraph of 35 U.S.C. 112:

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

2. Claims 3, 7, 11, 15 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.

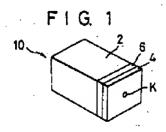
These claims are unclear because they do not have an ending period to indicate that the claim has ended.

## Claim Rejections - 35 USC § 102

3. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 4. Claims 1-17 are rejected under 35 U.S.C. 102(b) as being anticipated by Kobayashi et al (4,840,922). Kobayashi et al discloses the claimed invention. Note figure 1 which illustrates a near field light generating device (10) comprising a light



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emitting element (2) that emits light from its exit surface (cleavage plane); and a thin film (4) that is formed on the exit surface (cleavage plane) and gains a light transmitting property (see the abstract) when irradiated with light from the light emitting element (2).

It is inherent that the thin film essentially consists of inorganic material having a melting point equal to or lower than 350°C or 150°C, because Kobayashi et al teaches the same inorganic film as taught by applicant. For example Kobayashi et al's claim 6 names In and Sn as materials for the thin film (4). Note that these are materials also named by applicant for the thin film. See applicant's specification page 9 lines 10-12 for the teaching of In as the thin film and In having a melting point of about 130°C and see applicant's specification page 12 lines 3-8 for the teaching of Sn as the thin film and Sn having a melting point of about 232°C.

It is inherent that film (6) between the light exit surface (cleavage plane) and the thin film (4) is a heat diffusion preventing film, as claimed, because it is made of the same material taught by applicant—SiO<sub>2</sub>--.

Regarding the thin film (4) essentially consisting of an organic material, note Kobayashi et al's claim 24 for the teaching of organic materials: carbon, phthalocyanine and cyanine dye. It is noted that "low" melting point is subject to broad interpretation, e.g. between –1,000,000°C and 1,000,000°C, and therefore Kobayashi et al meets it.

#### Conclusion

5. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Mitarai et al (JP-10190120-A) teaches a semiconductor laser laminated with the same organic film—stearic acid-- as taught by applicant.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Quyen P. Leung whose telephone number is (703) 308-0545. The examiner can normally be reached on 8:30-5:00, M-F.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Paul Ip can be reached on (703) 308-3098. The fax phone numbers for the organization where this application or proceeding is assigned are (703) 308-7724 for regular communications and (703) 308-7724 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

Quyen P. Leung Primary Examiner Art Unit 2828

QPL March 29, 2002